

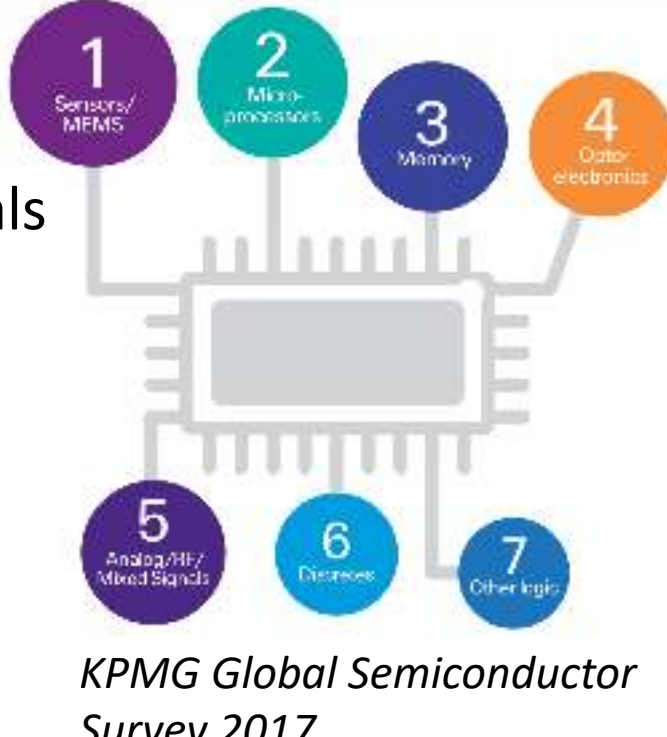
# Ab initio characterization of defect states in materials for next-generation technology

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## Motivations & State-of-the-art

- Incoming **limitations** of **Si-technology** & drive for improving **application range** of materials
- New complex non-Si-based materials** (chalcogenides, metal-oxides, ferroelectrics, etc.)
- Highly defective**, disordered and **amorphous** [1] with complex physical effects (electrical switching, quantum confinement, topology, spin, etc.)
- Material characteristics** interplay **Devices performances** (complex architectures, device reliability, etc.)
- Characterization/identification/control** of **defect states**: crucial to characterize properties of emerging **materials**, hence for design/optimization of **next-generation** electronic **devices**



Crucial also for understanding properties of already known **materials** at the **atomic level** [2] and reveal the connections between **atomic** and **electronic** structures

**Engineering** such materials through selective introduction of defects and/or dopants in order to **improve** their **application range**

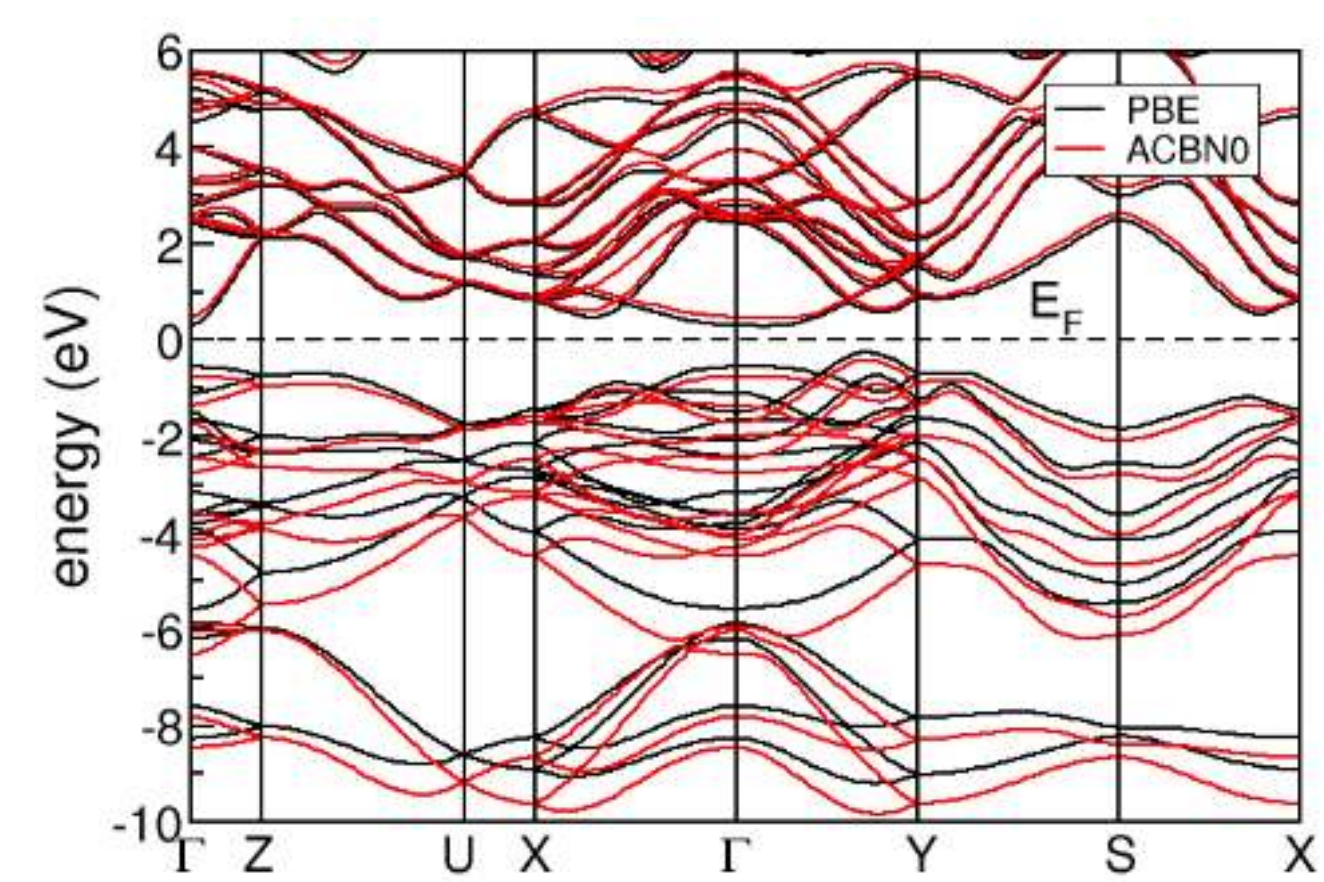
J. Chem. Phys. 154, 174704 (2021)

[1] M.-J. Lee, et al., Nat. Commun. 4, 2629 (2013); F. Tavanti et al., ACS Appl. Electron. Mater. 2, 2961 (2020)

[2] P. Mazzolini, et al., Adv. Electron. Mater. 2, 1500316 (2016); J. Osorio-Guillén et al., Phys. Rev. Lett. 100, 036601 (2008); J. Nowotny, et al., Chem. Soc. Rev., 44, 8424 (2015); M. Gerosa, et al., Nat. Mater. 17, 1122 (2018)

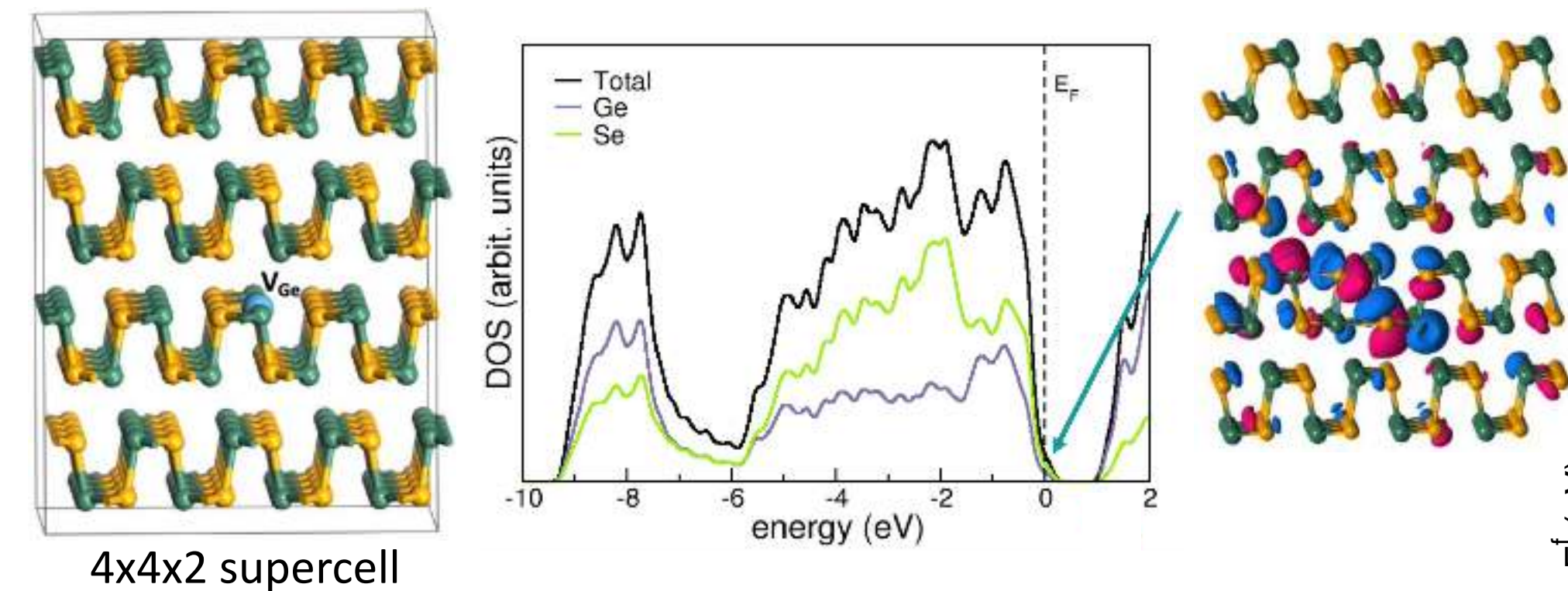
## Point defects in crystalline GeSe

### Bulk electronic structure of GeSe

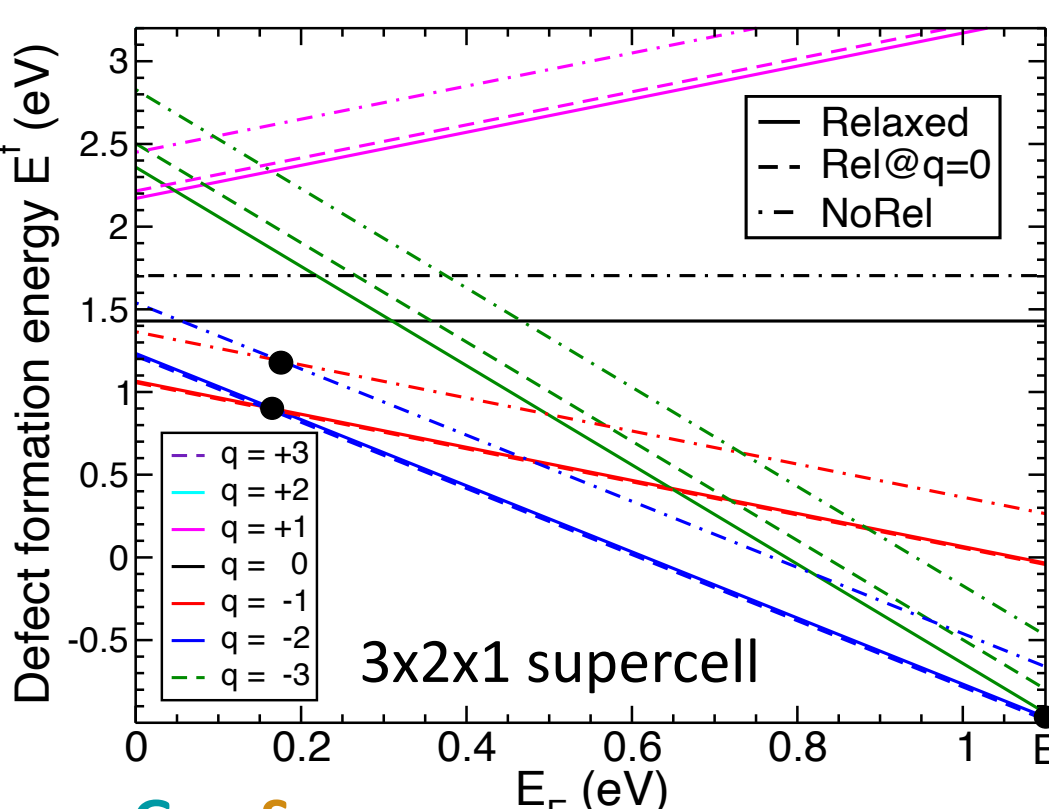


- Crystalline and amorphous chalcogenides promising for applications spanning from photoelectrocatalysis to memory devices and selectors for next generation electronics [1]
- GeSe**: Energy gap,  $E_g \approx 1.1$  eV, Fermi level ( $E_F$ ) indicated
- Orthorhombic cell
- Supercells** used for defect simulations
  - 3x2x1 (48 atoms)
  - 4x4x2 (256 atoms)
  - 5x4x2 (320 atoms)

### Ge vacancy

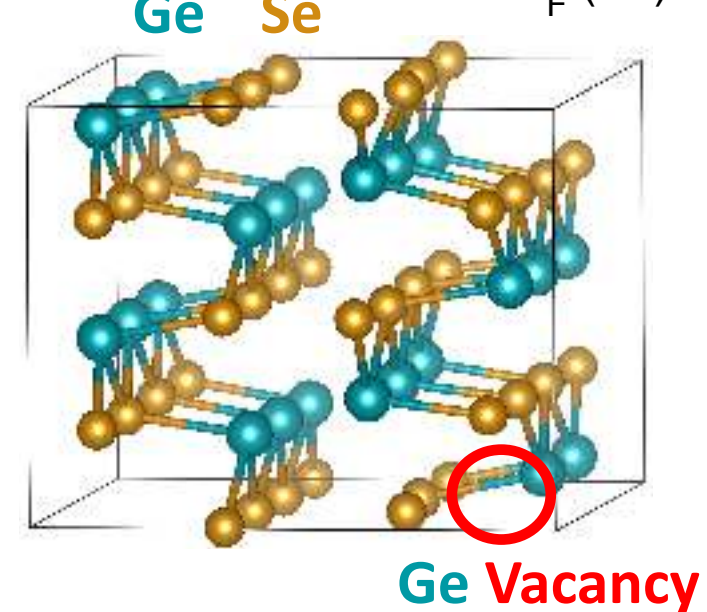


When a **Ge** vacancy is created, the density of states (DOS) shows a **partially occupied state** in the energy gap

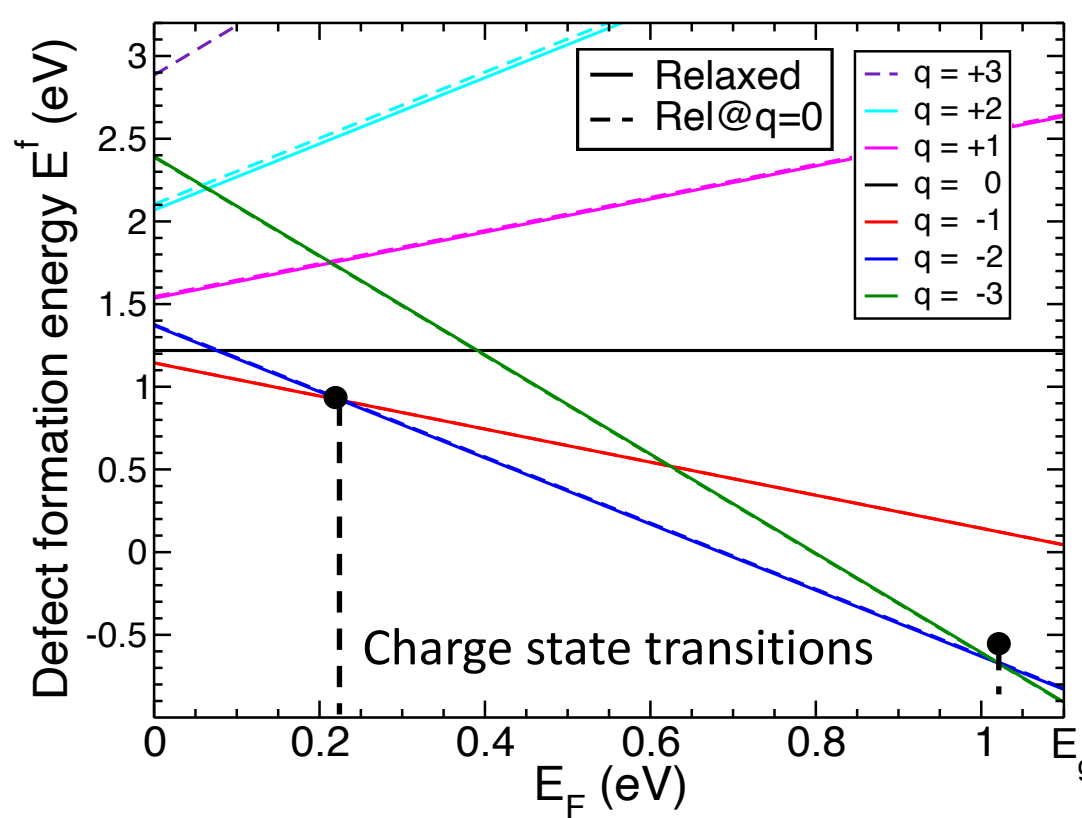


Defect formation energies as a function of **supercell size**: **convergence** is reached

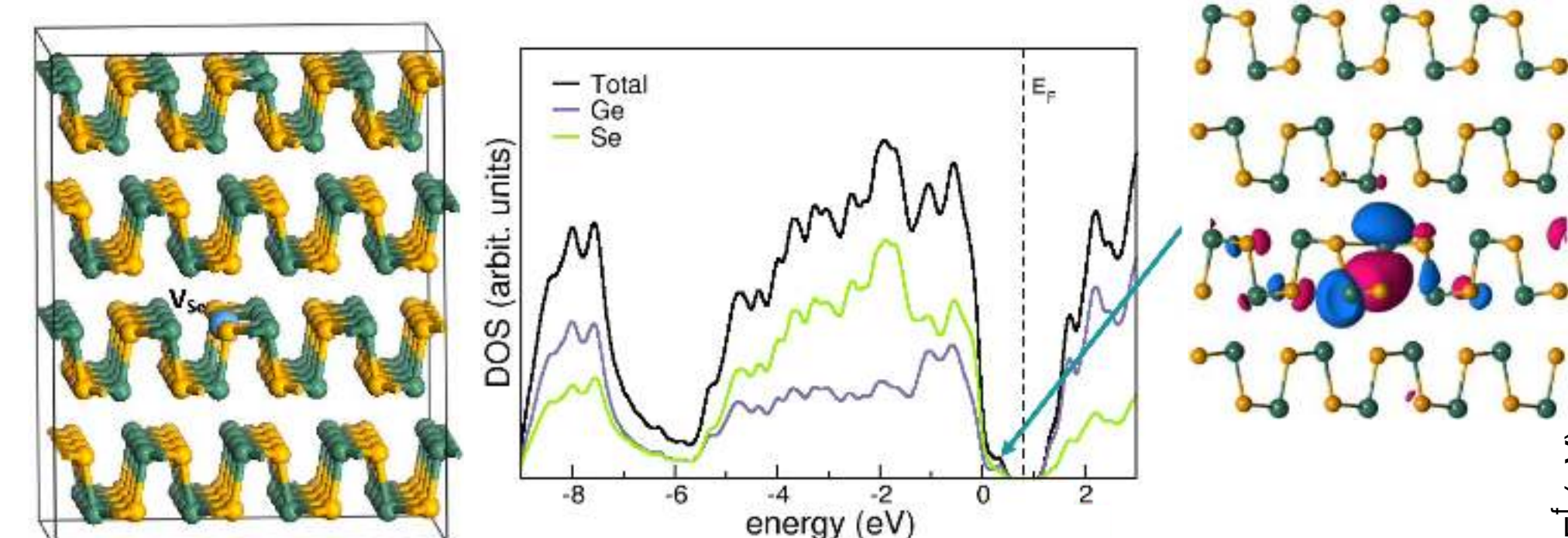
Effect of **structural relaxation** on defect stability: @charge state  $q$  vs @ $q=0$  vs no relaxation at all (3x2x1 supercell)



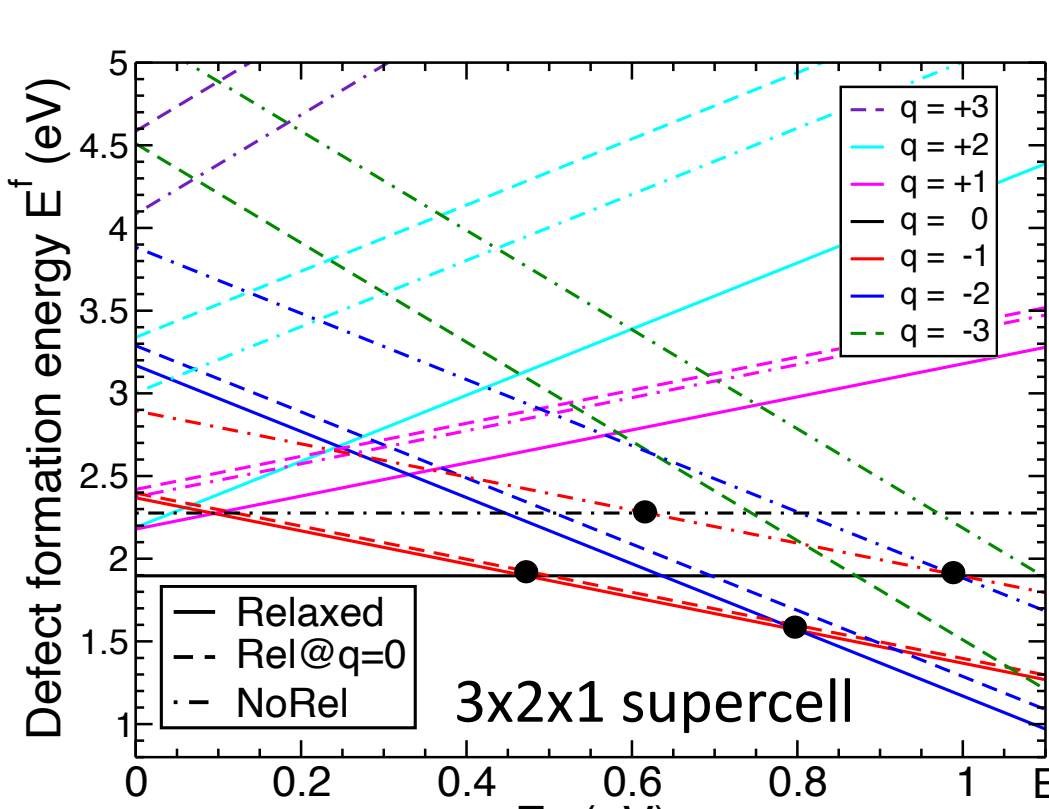
Characterization of **Ge** vacancy in crystalline GeSe: **stable charge states** across the gap & **charge state transitions** – well converged results (5x4x2 supercell)



### Se vacancy

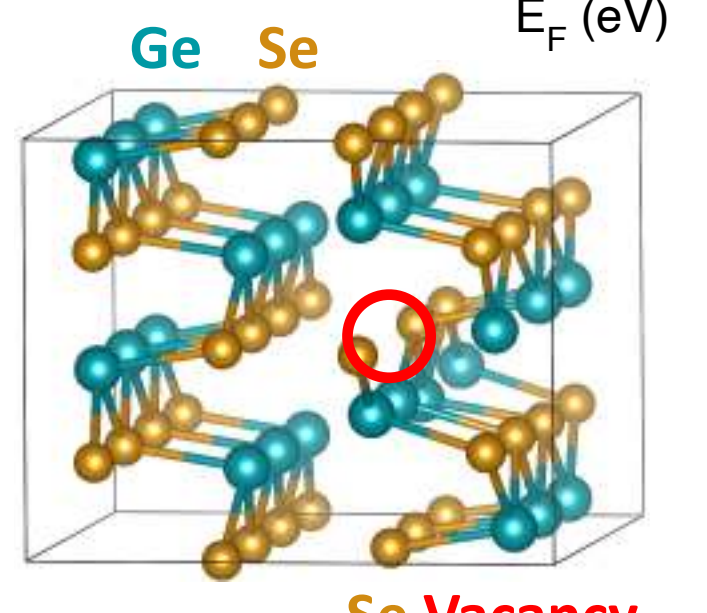


Defect state in the gap

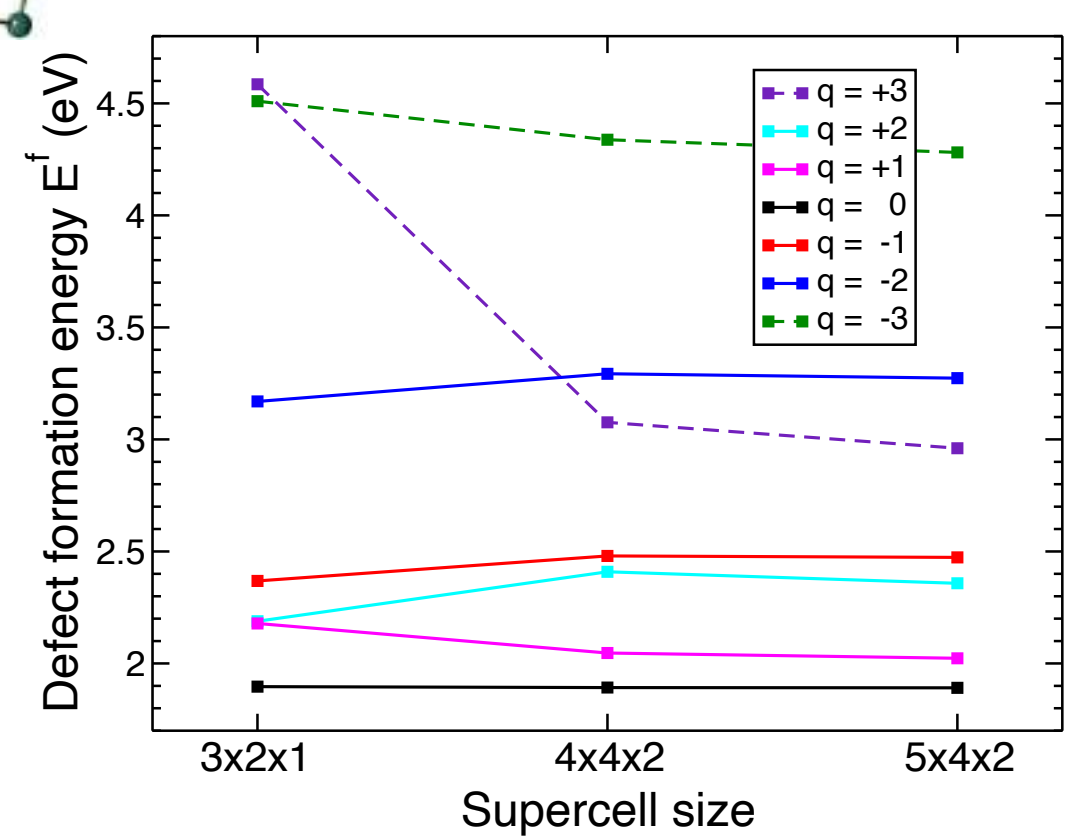


Defect formation energies as a function of **supercell size**: **convergence** is reached

Effect of **structural relaxation** on defect stability: @charge state  $q$  vs @ $q=0$  vs no relaxation at all (3x2x1 supercell)



Characterization of **Se** vacancy in crystalline GeSe: **stable charge states** across the gap & **charge state transitions** – well converged results (5x4x2 supercell)



**Defects dynamics** was addressed through nudged elastic band (NEB) simulations, which predict slightly **higher diffusion barriers** for **Se** vacancies (1.1 – 2.1 eV), compared to **Ge** ones (0.8 – 1.7 eV) – depending on the inequivalent diffusion path and charge state selected.

L. Bursi et al., to be submitted

## Methods

$$E^f[X^q] = E_{tot}[X^q] - E_{tot}[bulk] - \sum_i n_i \mu_i + q[E_v + E_F] + q\Delta V_{corr}$$

- $E_{tot}, E_v \rightarrow$  DFT-based (supercell) calculations
- $\mu_i \rightarrow$  DFT calculations + thermodynamic considerations



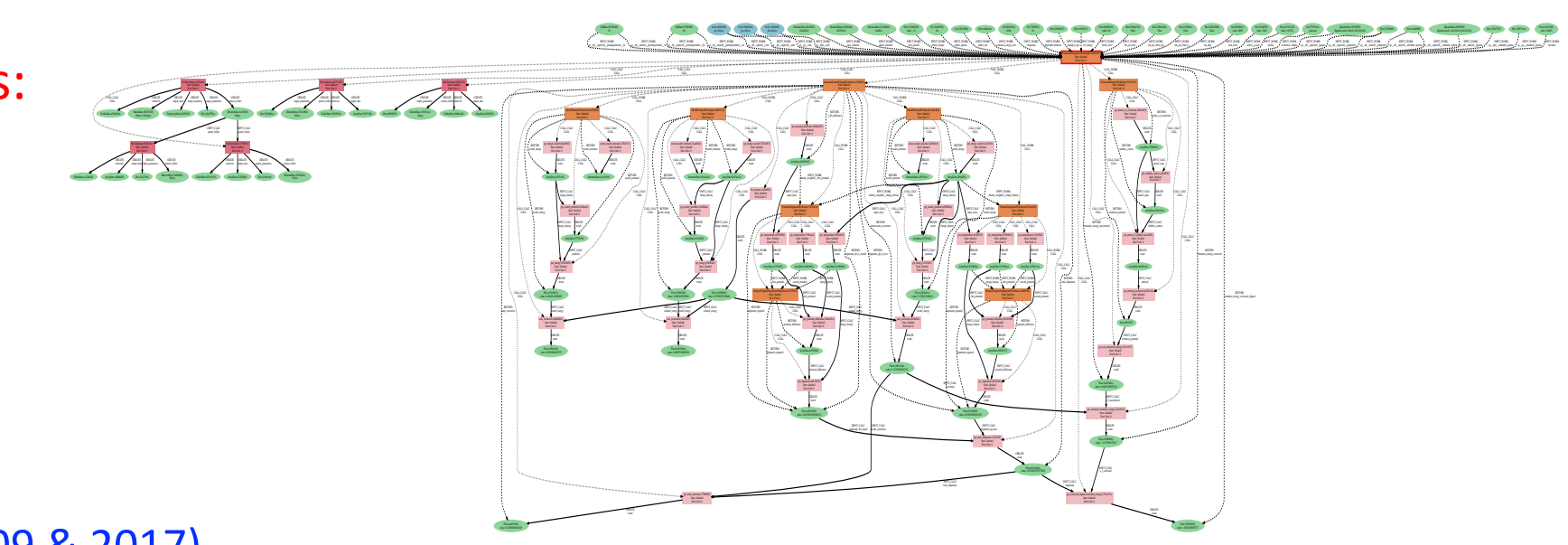
Approach developed by Freysoldt, Van de Walle and others, and generalized by Komsa and Pasquarello

$E_{corr} = q\Delta V_{corr}$  contains several contributions:

- Potential alignment;
- Image charge interaction;
- Spurious interactions;
- ...

**Electrostatic Gaussian counter-charge scheme**

- P. Giannozzi et al., J. Phys.: Condens. Matter 21, 395502 (2009 & 2017)
- C. Freysoldt, et al., Phys. Rev. Lett. 102, 016402 (2009)
- C. Freysoldt, et al., Rev. Mod. Phys. 86, 253 (2014)
- J. Buckeridge, et al., Comput. Phys. Commun. 185, 330 (2014)
- J. Buckeridge, Comput. Phys. Commun. 244, 329 (2019)
- H.-P. Komsa, et al., Phys. Rev. Lett. 110, 095505 (2013)
- I. Dabo, et al., Phys. Rev. B 77, 115139 (2008)



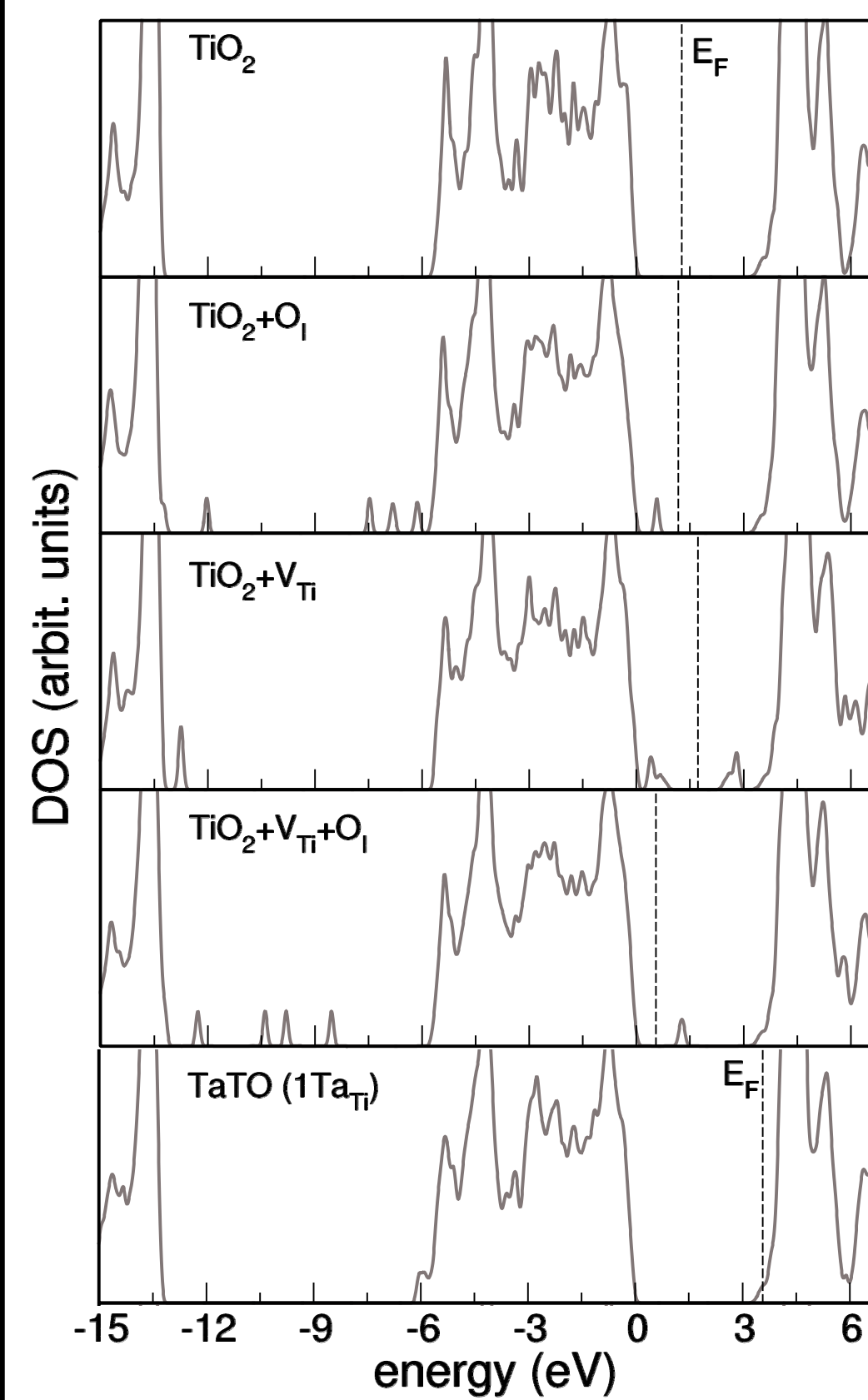
Towards full **automation** of defect calculations

G. Pizzi, et al., Comp. Mat. Sci. 111, 218 (2016) <http://www.aiiida.net>

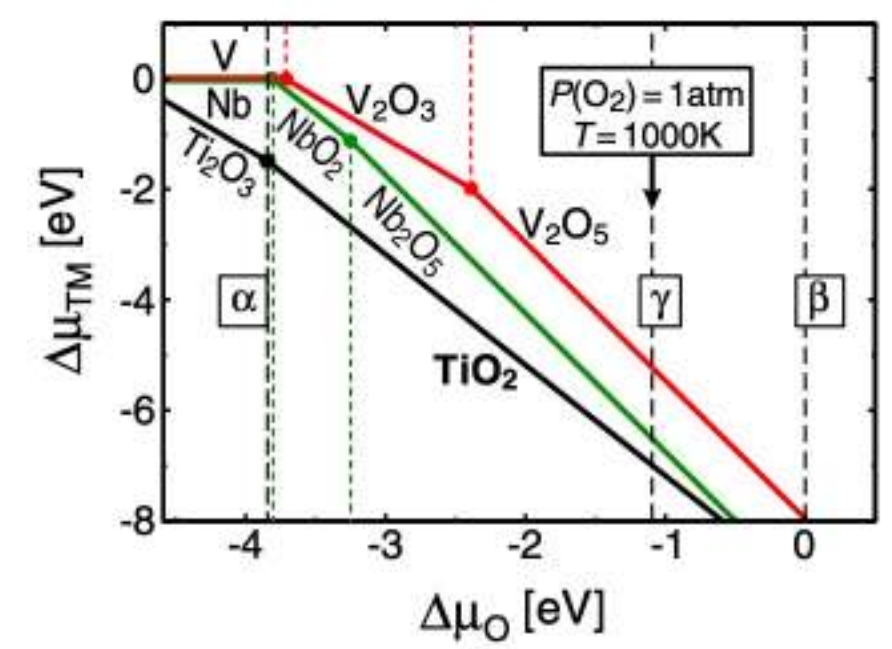
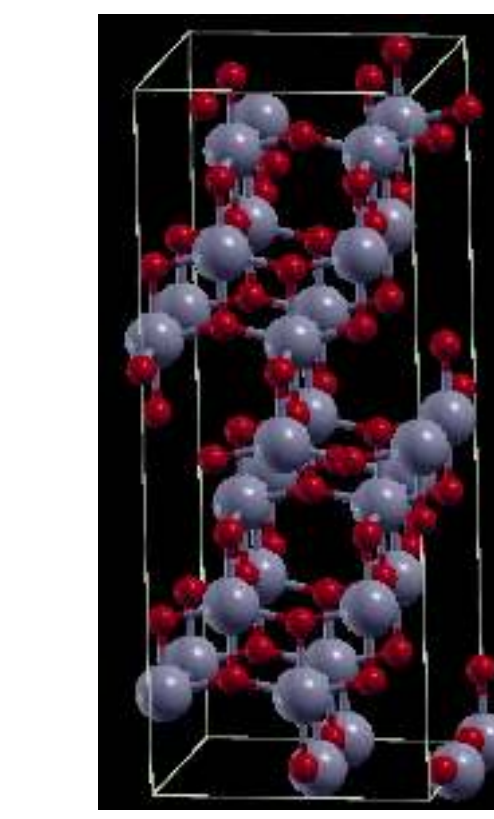


## Point defects in anatase TiO<sub>2</sub>

### Electronic structure of anatase TiO<sub>2</sub>: host and selected defective structures

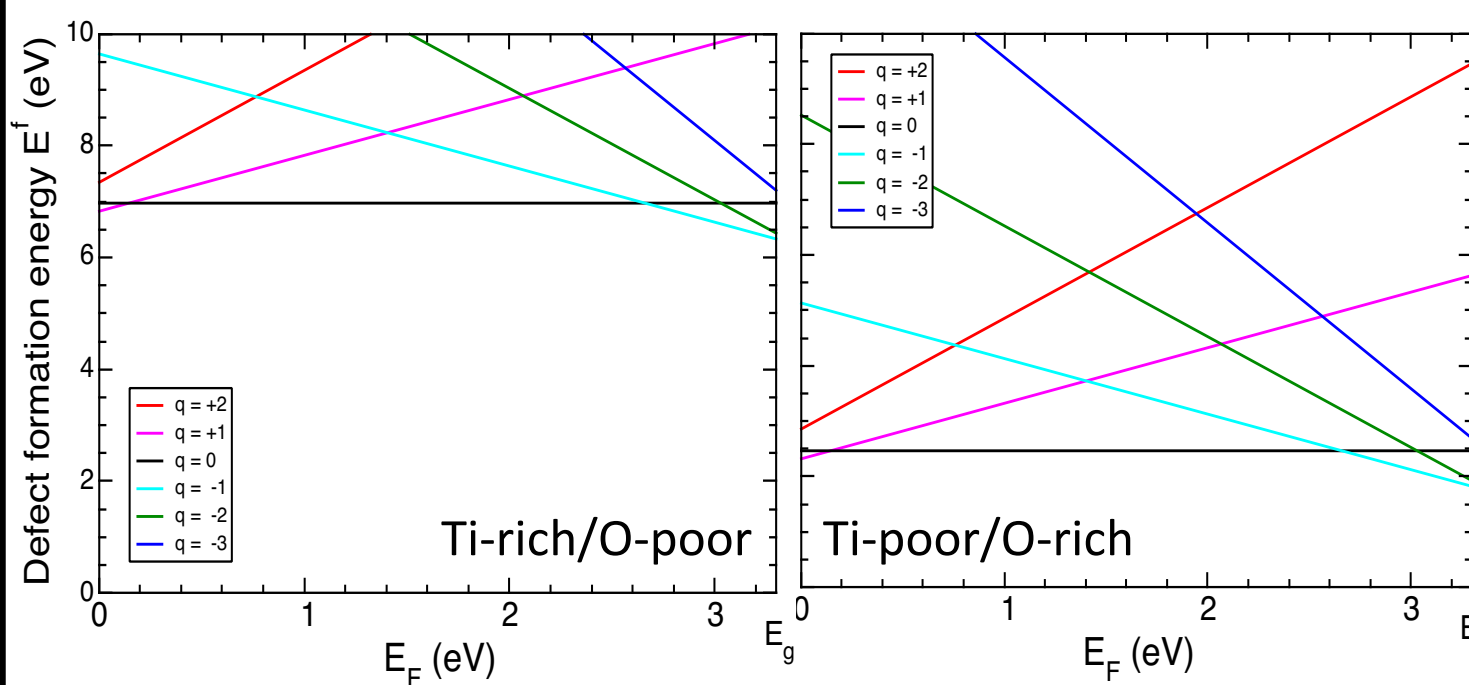


- TiO<sub>2</sub>** – well-known material with a wide range of applications spanning from photocatalysis to memory devices and transparent conductivity (TC)
- Relatively less studied **Ta-doped TiO<sub>2</sub> (TaTO)** – promising mobility and dopant solubility for TC [2]. Here we focus on O-rich condition
- TiO<sub>2</sub>**:  $E_g \approx 3.3$  eV,  $E_F$  indicated
- Defects introduce deep **states in the gap**
- Supercell** used for defect simulations: 2x2x2 (96 atoms)

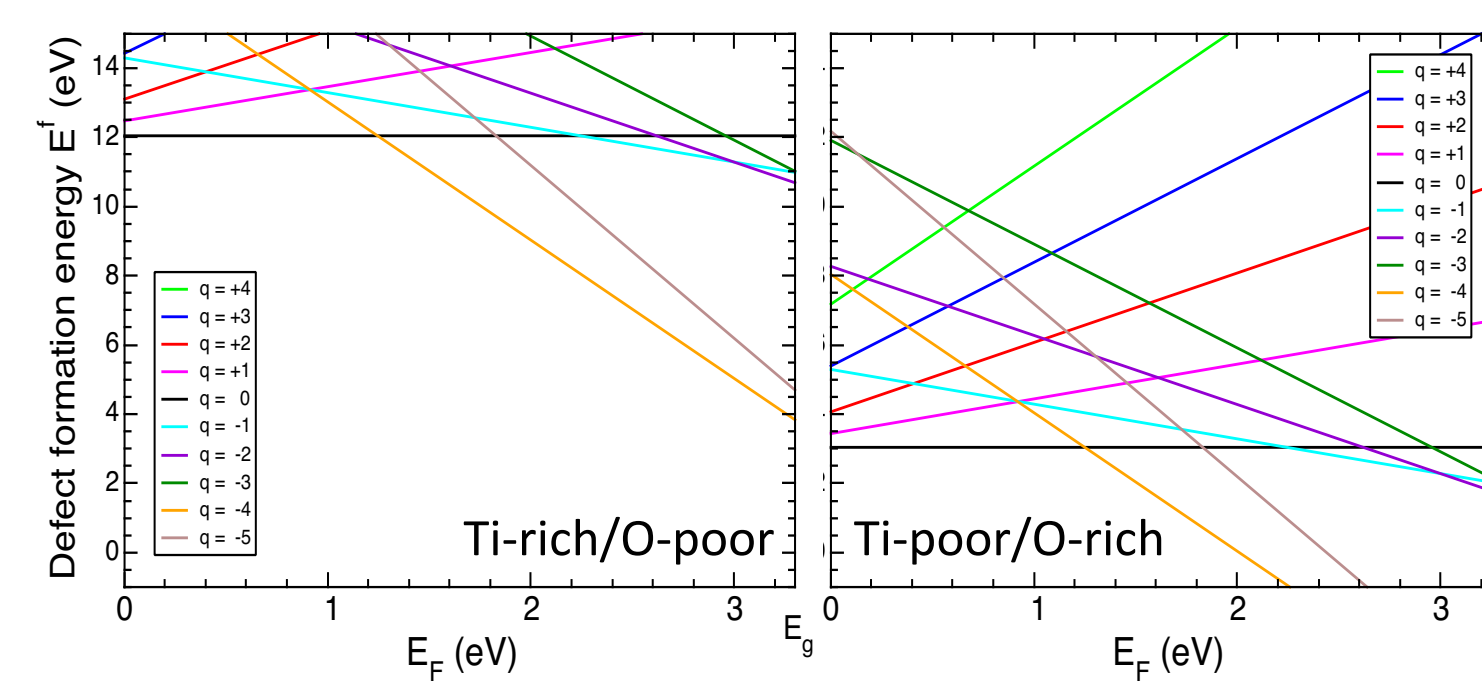


J. Osorio-Guillén et al., Phys. Rev. Lett. 100, 036601 (2008)

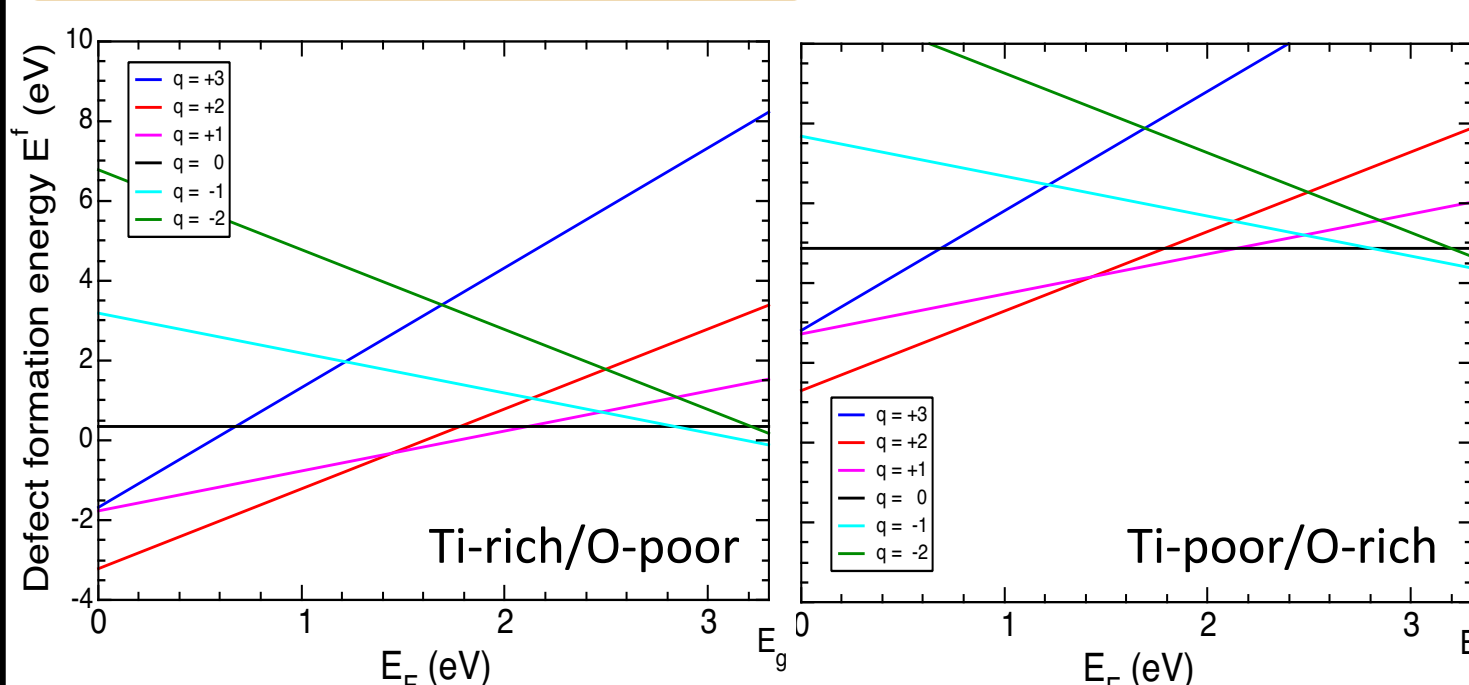
### O interstitial, O<sub>i</sub>



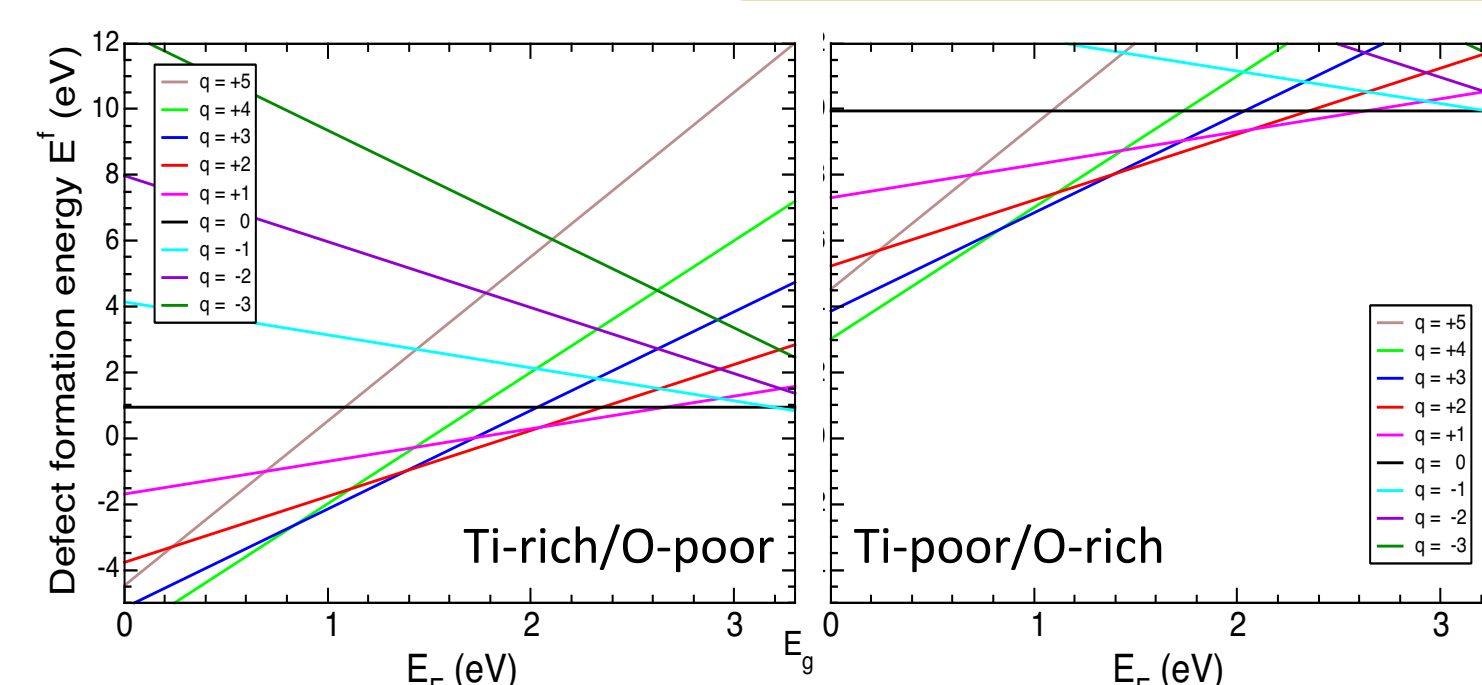
### Ti vacancy, V<sub>Ti</sub>



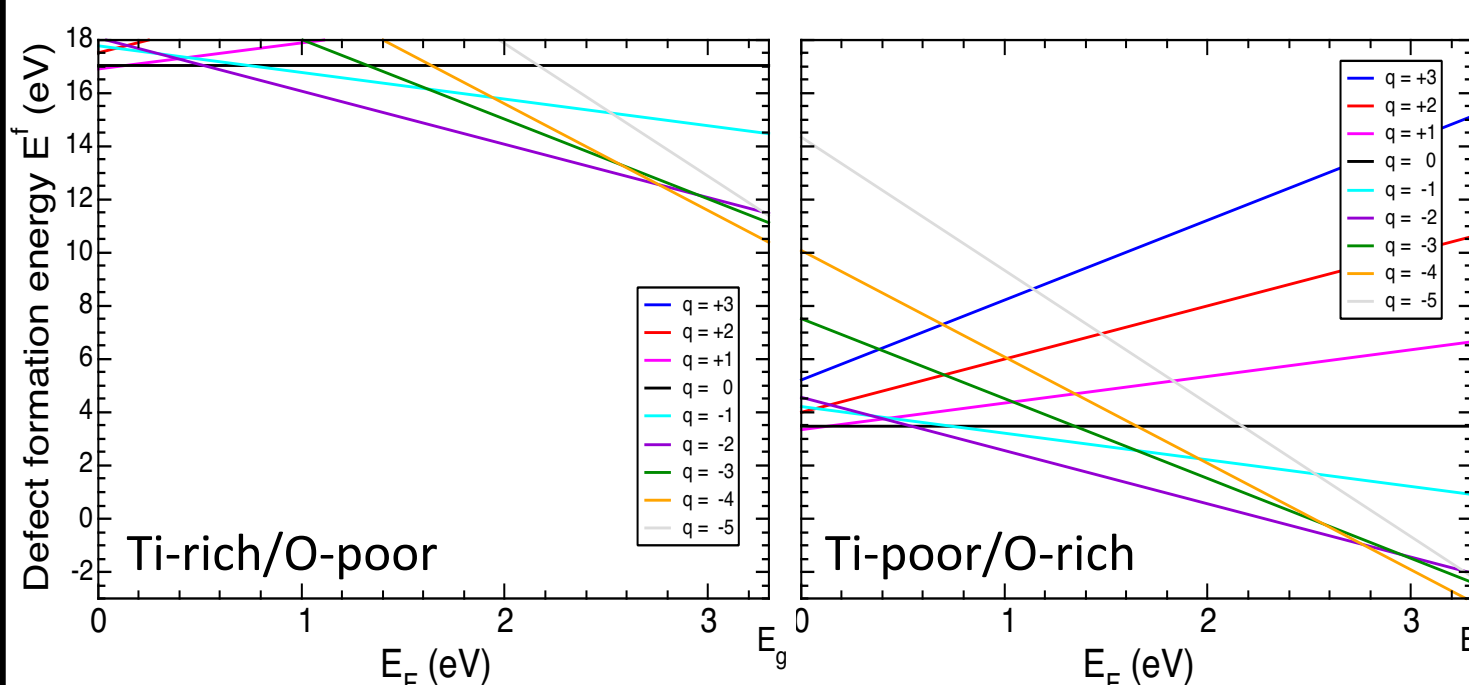
### O vacancy, V<sub>O</sub>



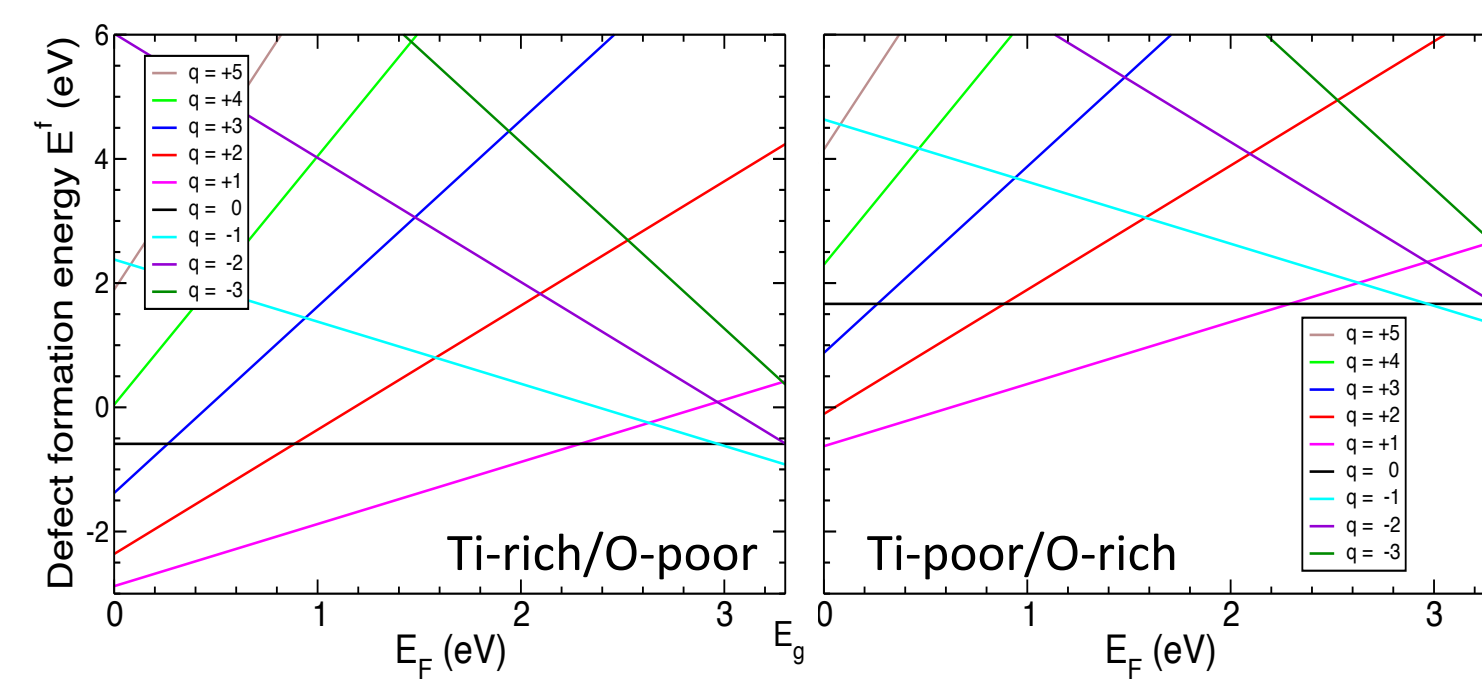
### Ti interstitial, Ti<sub>i</sub>



### Double defect: O<sub>i</sub> + V<sub>Ti</sub>



### Ta substitutional, Ta<sub>Ti</sub>



- O<sub>i</sub>** and **V<sub>Ti</sub>** have high formation energies in **O-poor** condition, while **V<sub>O</sub>** and **Ti<sub>i</sub>** in **O-rich** condition, as expected
- Ta<sub>Ti</sub>** is relatively **easy to form** and has **charge state transitions** within a few meV from the conduction band
- Similarly, the formation energy of **O<sub>i</sub>+V<sub>Ti</sub>** defect is relatively low in **O-rich** condition
- Intrinsic acceptors do not form easily under O-poor condition, the situation is more complex in O-rich condition

A. Calzolari, L. Bursi et al., in preparation

## Conclusion and acknowledgement

### Final remarks

- Search for alternative **materials** and **architectures** for next-generation electronics to overcome incoming **limitations** of **Si-based** technology and **engineering** known materials to improve their **applications**
- Automatic** simulations of **point defects thermodynamics** in solids (**GeSe** & **TiO<sub>2</sub>**) through the **AiiDA workflow**: **Defect formation energies**, stability & **charge state transitions** characterized
- Defect **dynamics** simulations predict slightly **larger mobility** for **Ge** vacancies compared to **Se** ones

### Collaborators:

Dr. Conrad Johnston & Dr. Sokseha Muy from Dr. Marzari's group at **EPFL**

### Funding:



**Interoperable Material -to-Device simulation box** for disruptive electronics